

5/14/2007

Docket No.: SUG-176-USAP

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/718,789

Confirmation No.: 1591

Applicant: Kazunori HAGIMOTO et al.

Art Unit: 2814

Filed: November 24, 2003

Examiner: Howard Weiss

Docket No: SUG-176-USAP

Customer No: 28892

For: Light-Emitting Device, Method of Fabricating the Same, and

OHMIC Electrode Structure for Semiconductor Device

INFORMATION DISCLOSURE STATEMENT - PTO FORM 1449

U.S. PATENT DOCUMENTS					
Examiner Initials*	U.S. Patent Document Number	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY		
	5,917,202 (JP 9-186365)	Haitz et al.	06-29-1999		

FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Foreign Patent Document Number	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T**			
	JP 2001-7389 (w/ Eng. Abstract)	Tokyo Shibaura Electric Co.	01-12-2001				
	JP 9-186365 (w/ Eng. Abstract) (5,917,202)	Hewlett Packard Co.	07-15-1997				
	JP 5-251739 (w/ Eng. Abstract)	Tokyo Shibaura Electric Co.	09-28-1993				

Examiner /Howard Weiss/ Signature	Date Considered	09/28/2007
--------------------------------------	--------------------	------------

^{*}Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /HW/

^{**}Applicant is to place a check mark here if English language translation is attached